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July 3, 2003

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Application of Hironori ENDO
LIQUID EJECTION CONTROL METHOD AND LIQUID EJECTION
APPARATUS
Assignee: SEIKO EPSON CORPORATION
Our Ref. Q76423

Dear Sir:

Attached hereto is the application identified above comprising forty-six (46) sheets of the specification (Japanese Language), including the claims and abstract and twelve (12) sheets of drawings. The requisite U.S. Government filing fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total claims	<u>19</u>	-	20	=	<u> </u>	x	\$18.00	=	<u> </u>	\$0.00		
Independent claims	<u>1</u>	-	3	=	<u> </u>	x	\$84.00	=	<u> </u>	\$0.00		
Base Fee											<u> </u>	\$750.00
TOTAL FEE											<u> </u>	\$750.00

TOTAL FEE



MAIL STOP PATENT APPLICATION
Attorney Docket No. **Q76423**

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2002-197598	July 5, 2002
Japan	2002-286930	September 30, 2002

The priority documents are enclosed herewith.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

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